

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Seong Deok Ahn et al.

Application No.: 10/672,013

Filed: September 26, 2003

For: **Method and Apparatus Using Large-Area
Organic Vapor Deposition for Formation of
Organic Thin Films or Organic Devices**

Examiner: Richard R. Bueker

Art Unit: 1763

Confirmation No.: 7684

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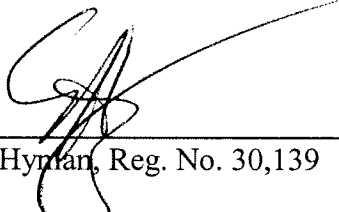
of this Information Disclosure Statement, please charge those fees to our Deposit Account No. 02-2666.

Respectfully submitted,

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Dated: August 8, 2007

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